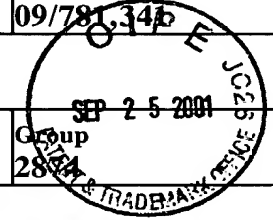


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Patent and Trademark OfficeAtty. Docket No.  
0980/62251-CSerial No.  
09/781,345INFORMATION DISCLOSURE CITATION  
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GW	AA	5	4	1	8	8	6	7	05/23/95	Van Der Tol			
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													Yes	No
GW	AJ	WO	99	6	4	9	0	3	12/16/99	PCT	✓			
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GW	AL	Russell, Knight, Birks, Mangan, and Wadsworth, "Recent Progress in Photonic Crystal Fibres, ThG1-1 - ThG-3,980100, Optical Fiber Communication Conference, 2000, Technical Digest Series, Conference Edition, Baltimore, Maryland, March 7-10, 2000 (Optical Society of America)" ✓											
GW	AM	Monro, Bennett, Broderick, and Richardson, "New Possibilities with Holey Fibers," ThG4-1 - ThG4-3, 106-108 Optical Fiber Communication Conference, 2000, Technical Digest Series, Conference Edition, Baltimore, Maryland, March 7-10, 2000 (Optical Society of America)" ✓											
GW	AN	Windeler and Ranka, "Novel Properties of Air-Silica Microstructure Optical Fibers," ThG3-1 - ThG3-2, 104-105 Optical Fiber Communication Conference, 2000, Technical Digest Series, Conference Edition, Baltimore, Maryland, March 7-10, 2000 (Optical Society of America)" ✓											
GW	AO	Broeng, Barkou, and Bjarkley, "Polarization Properties of Photonic Bandgap Fibers," ThG2-1 - ThG2-3, 101-103 Optical Fiber Communication Conference, 2000, Technical Digest Series, Conference Edition, Baltimore, Maryland, March 7-10, 2000 (Optical Society of America)" ✓											

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							Yes	No
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GNW	AH	Dutton, <i>Understanding Optical Communications</i> (Prentice-Hall 1998), Contents and pages 42-45
GNW	AI	Hecht, <i>Understanding Fiber Optics</i> , 3rd ed. (Prentice-Hall 1999), Contents and pages 68-73
GNW	AJ	Keiser, <i>Optical Fiber Communications</i> , 3rd ed. (McGraw-Hill 2000), Contents and pages 70-75
GNW	AK	<a href="http://www.blazephotonics.com/pages/techn.htm">http://www.blazephotonics.com/pages/techn.htm</a> - dated 03/30/01
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GNW	AM	U.S. Application Serial No. 09/781,344, filed 02/12/01
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GNW	AP	Wu, B., and Chu, P., "Fabrication of High Concentration Rare-Earth-Doped Silica-Based Waveguide by MCVD Method," <i>IEEE Photonics Technology Letters</i> , Vol. 7, No. 6 (June 1995), pp. 655-657.

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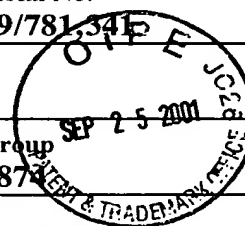
U.S. Department of Commerce  
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0980/62251-C

Serial No.

09/781,341

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GW	AH	Kilian, A. et al., "Birefringence Free Planar Optical Waveguide Made by Flame Hydrolysis Deposition (FHD) Through Tailoring of the Overcladding," Journal of Lightwave Technology, Vol. 18, No. 2 (February 2000), pp. 193-198. ✓
GW	AI	Suzuki, S., et al., "Integrated-Optic Ring Resonators with Two Stacked Layers of Silica Waveguide on Si," IEEE Photonics Technology Letters, Vol. 4, No. 11 (November 1992), pp. 1256-1258. ✓
GW	AJ	Cheng, Y. et al., "Localized Silicon Fusion and Eutectic Bonding for MEMS Fabrication and Packaging," IEEE Journal of Microelectromechanical Systems, Vol. 9, No. 1 (March 2000), pp 1-8. ✓
GW	AK	Maszara, W. et al., "Bonding of Silicon Wafers for Silicon-on-Insulator," Journal of Applied Physics 64 (10) (15 November 1998), pp. 4943-4950. ✓
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Atty. Docket No.  
**0980/62251-C**

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**09/781,341**

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**Shih-Yuan Wang**

Filing Date  
**February 12, 2001**

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	AF												
	AG												
	AH												
	AI												


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		Document Number							Date	Country	Class	Subclass	Translation	
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GM	AL	Plummer, <i>Silicon VLSI Technology: Fundamentals, Practice and Modeling</i> , Prentice Hall (2000), Cover page and table of contents.
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